



SMC-02-709

December 12, 2003

To: Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Fr: George O. Saile, Reg. No. 19,572  
28 Davis Avenue  
Poughkeepsie, N.Y. 12603

Subject: | Serial No. 10/661,792 09/12/03 |  
Hsu Ming Ta  
A WEB SERVICE AND METHOD FOR  
CUSTOMERS TO DEFINE THEIR OWN ALERT  
FOR REAL-TIME PRODUCTION STATUS  
| \_\_\_\_\_ |

INFORMATION DISCLOSURE STATEMENT

Enclosed is Form PTO-1449, Information Disclosure Citation  
In An Application.

The following Patents and/or Publications are submitted to  
comply with the duty of disclosure under CFR 1.97-1.99 and  
37 CFR 1.56.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being  
deposited with the United States Postal Service as first class  
mail in an envelope addressed to: Commissioner for Patents,  
P.O. Box 1450, Alexandria, VA 22313-1450, on December 19, 2003.

Stephen B. Ackerman, Reg.# 37761

Signature/Date SB Ackerman 12/19/03

TSMC-02-709

U.S. Patent 6,408,220 to Nulman, "Semiconductor Processing Techniques," discusses semiconductor processing techniques in manufacturing.

U.S. Patent 6,397,116 to Matsumoto, "Production Control System and Method," discusses a production control system and method.

U.S. Patent 6,259,956 to Myers et al., "Method and Apparatus for Site Management," discusses a method and apparatus for site management of unattended robots storage and dispensing sites.

Sincerely

A handwritten signature in black ink, appearing to read 'SBA', with a long horizontal flourish extending to the right.

Stephen B. Ackerman,  
Reg. No. 37761

## INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets if necessary)

Docket Number (Criminal)

TSmc-02-709

Application Number

10/661,792

Applicant

Applicant Hsu Ming Ta

Filing Date

Filing Date 09/12/03

Group Art Unit

## U. S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Portion or Pages, Etc.)

[illegible]

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.